



**ELECTRONIC COPY**

LG814631022  
Report verification at [igi.org](http://igi.org)



July 4, 2026  
IGI Report Number **LG814631022**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **9.84 X 6.98 X 4.63 MM**  
**GRADING RESULTS**  
Carat Weight **3.00 CARATS**  
Color Grade **FANCY INTENSE YELLOW**  
Clarity Grade **VS 2**

**LABORATORY GROWN DIAMOND REPORT**

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Measurements **9.84 X 6.98 X 4.63 MM**

**GRADING RESULTS**

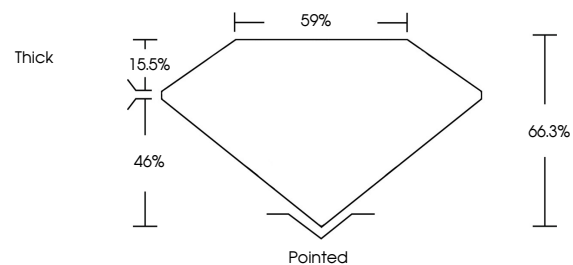
Carat Weight **3.00 CARATS**  
Color Grade **FANCY INTENSE YELLOW**  
Clarity Grade **VS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG814631022**

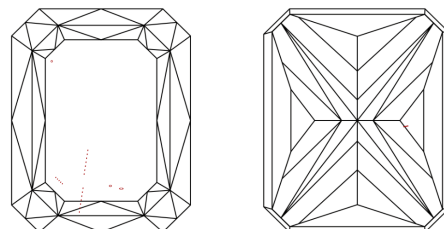
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

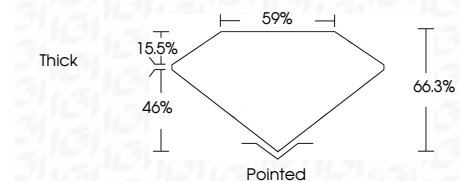
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
9.84 X 6.98 X 4.63 MM  
3.00 CARATS  
FANCY INTENSE YELLOW  
VS 2  
66.3%  
59%  
Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG814631022  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.